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 PALM INTRANET**Inventor Name Search Result**

Your Search was:

Last Name = TANIGUCHI

First Name = YUKIO

Application#	Patent#	Status	Date Filed	Title	Inventor Name
<u>11194607</u>	Not Issued	020	08/02/2005	SEMICONDUCTOR DEVICE INCLUDING SEMICONDUCTOR THIN FILM, WHICH IS SUBJECTED TO HEAT TREATMENT TO HAVE ALIGNMENT MARK, CRYSTALLIZING METHOD FOR THE SEMICONDUCTOR THIN FILM, AND CRYSTALLIZING APPARATUS FOR THE SEMICONDUCTOR THIN FILM	TANIGUCHI, YUKIO
<u>11178562</u>	Not Issued	030	07/12/2005	METHOD OF PICKING UP SECTIONAL IMAGE OF LASER LIGHT	TANIGUCHI, YUKIO
<u>11118479</u>	Not Issued	030	05/02/2005	METHOD AND APPARATUS FOR FORMING PATTERN ON THIN SUBSTRATE OR THE LIKE	TANIGUCHI, YUKIO
<u>11098647</u>	Not Issued	020	04/05/2005	CRYSTALLIZATION APPARATUS, CRYSTALLIZATION METHOD, AND PHASE MODULATION DEVICE	TANIGUCHI, YUKIO
<u>11087619</u>	Not Issued	020	03/24/2005	CRYSTALLIZATION APPARATUS, CRYSTALLIZATION METHOD, DEVICE, OPTICAL MODULATION ELEMENT, AND DISPLAY APPARATUS	TANIGUCHI, YUKIO
<u>11051189</u>	Not Issued	030	02/07/2005	LIGHT IRRADIATION APPARATUS, LIGHT IRRADIATION METHOD, CRYSTALLIZATION	TANIGUCHI, YUKIO

				APPARATUS, CRYSTALLIZATION METHOD, DEVICE, AND LIGHT MODULATION ELEMENT	
<u>11041832</u>	Not Issued	030	01/25/2005	LIGHT APPLICATION APPARATUS, CRYSTALLIZATION APPARATUS AND OPTICAL MODULATION ELEMENT ASSEMBLY	TANIGUCHI, YUKIO
<u>11041413</u>	Not Issued	020	01/25/2005	SEMICONDUCTOR DEVICE, ANNEALING METHOD, ANNEALING APPARATUS AND DISPLAY APPARATUS	TANIGUCHI, YUKIO
<u>10985935</u>	Not Issued	030	11/12/2004	ORAL AIRWAY AND AIRWAY MANAGEMENT ASSISTIVE DEVICE PROVIDED WITH THE ORAL AIRWAY	TANIGUCHI, YUKIO
<u>10958396</u>	Not Issued	030	10/06/2004	CRYSTALLIZATION APPARATUS AND CRYSTALLIZATION METHOD	TANIGUCHI, YUKIO
<u>10949417</u>	Not Issued	020	09/27/2004	CRYSTALLIZATION APPARATUS, CRYSTALLIZATION METHOD, DEVICE AND PHASE MODULATION ELEMENT	TANIGUCHI, YUKIO
<u>10878331</u>	Not Issued	030	06/29/2004	CRYSTALLIZATION METHOD, CRYSTALLIZATION APPARATUS, PROCESSED SUBSTRATE, THIN FILM TRANSISTOR AND DISPLAY APPARATUS	TANIGUCHI, YUKIO
<u>10845226</u>	Not Issued	030	05/14/2004	INTERVERTEBRAL SPACER	TANIGUCHI, YUKIO
<u>10802836</u>	Not Issued	030	03/18/2004	METHOD AND APPARATUS FOR FORMING CRYSTALLINE PORTIONS OF SEMICONDUCTOR FILM	TANIGUCHI, YUKIO
<u>10790828</u>	Not Issued	020	03/03/2004	CRYSTALLIZATION APPARATUS, CRYSTALLIZATION METHOD, PHASE	TANIGUCHI, YUKIO

				MODULATION ELEMENT, DEVICE AND DISPLAY APPARATUS	
<u>10734248</u>	Not Issued	030	12/15/2003	CRYSTALLIZATION APPARATUS, CRYSTALLIZATION METHOD, AND PHASE SHIFT MASK	TANIGUCHI, YUKIO
<u>10724261</u>	Not Issued	030	12/01/2003	CRYSTALLIZATION APPARATUS AND CRYSTALLIZATION METHOD	TANIGUCHI, YUKIO
<u>10692798</u>	Not Issued	071	10/27/2003	CRYSTALLIZATION APPARATUS AND CRYSTALLIZATION METHOD	TANIGUCHI, YUKIO
<u>10685494</u>	<u>6927839</u>	150	10/16/2003	METHOD AND APPARATUS FOR FORMING PATTERN ON THIN SUBSTRATE OR THE LIKE	TANIGUCHI, YUKIO
<u>10668285</u>	<u>6870126</u>	150	09/24/2003	SEMICONDUCTOR DEVICE, ANNEALING METHOD, ANNEALING APPARATUS AND DISPLAY APPARATUS	TANIGUCHI, YUKIO
<u>10661600</u>	Not Issued	041	09/15/2003	CRYSTALLIZATION APPARATUS, CRYSTALLIZATION METHOD, AND PHASE SHIFT MASK AND FILTER FOR USE IN THESE APPARATUS AND METHOD	TANIGUCHI, YUKIO
<u>10656202</u>	Not Issued	071	09/08/2003	CRYSTALLIZATION APPARATUS, CRYSTALLIZATION METHOD, AND PHASE SHIFTER	TANIGUCHI, YUKIO
<u>10624555</u>	Not Issued	041	07/23/2003	CRYSTALLIZATION APPARATUS, CRYSTALLIZATION METHOD, THIN FILM TRANSISTOR AND DISPLAY APPARATUS	TANIGUCHI, YUKIO
<u>10603821</u>	Not Issued	089	06/26/2003	CRYSTALLIZATION APPARATUS, OPTICAL MEMBER FOR USE IN CRYSTALLIZATION APPARATUS,	TANIGUCHI, YUKIO

				CRYSTALLIZATION METHOD, MANUFACTURING METHOD OF THIN FILM TRANSISTOR, AND MANUFACTURING METHOD OF MATRIX CIRCUIT SUBSTRATE OF DISPLAY	
<u>10603771</u>	Not Issued	089	06/26/2003	CRYSTALLIZATION APPARATUS, OPTICAL MEMBER FOR USE IN CRYSTALLIZATION APPARATUS, CRYSTALLIZATION METHOD, THIN FILM TRANSISTOR, AND DISPLAY	TANIGUCHI, YUKIO
<u>10458387</u>	<u>6816231</u>	150	06/09/2003	METHOD AND APPARATUS FOR EXPOSURE	TANIGUCHI, YUKIO
<u>10383332</u>	<u>6819401</u>	150	03/07/2003	EXPOSURE METHOD AND APPARATUS	TANIGUCHI, YUKIO
<u>10366754</u>	Not Issued	095	02/13/2003	METHOD AND APPARATUS FOR FORMING A SEMICONDUCTOR THIN FILM	TANIGUCHI, YUKIO
<u>10269205</u>	Not Issued	092	10/10/2002	EXPOSURE METHOD AND APPARATUS FOR PRODUCING A HOLOGRAM MASK AND RECORDING METHOD USING THE HOLOGRAM MASK	TANIGUCHI, YUKIO
<u>10241676</u>	<u>6900827</u>	150	09/10/2002	OPTICAL RECORDER AND METHOD THEREOF	TANIGUCHI, YUKIO
<u>10119779</u>	Not Issued	041	04/11/2002	SURGICAL INSTRUMENT	TANIGUCHI, YUKIO
<u>09691158</u>	<u>6491725</u>	150	10/19/2000	KEYHOLE BUTTON	TANIGUCHI, YUKIO
<u>09606311</u>	<u>6340540</u>	150	06/29/2000	HOLOGRAM RECORDING SHEET, HOLOGRAPHIC OPTICAL ELEMENT USING SAID SHEET, AND ITS PRODUCTION PROCESS	TANIGUCHI, YUKIO
<u>08935301</u>	<u>5981123</u>	150	09/22/1997	ELECTROSTATIC INFORMATION RECORDING MEDIUM AND ELECTRO-STATIC INFORMATION RECORDING AND REPRODUCING METHOD	TANIGUCHI, YUKIO

<u>08897088</u>	<u>6127066</u>	150	07/18/1997	HOLOGRAM RECORDING SHEET, HOLOGRAPHIC OPTICAL ELEMENT USING SAID SHEET, AND ITS PRODUCTION PROCESS	TANIGUCHI, YUKIO
<u>08859910</u>	<u>6033810</u>	150	05/21/1997	MOLDED ARTICLES USING GLASS AS SUBSTRATE, SUCH AS HOLOGRAPHIC OPTICAL ELEMENT, OPTICAL REFLECTOR AND ENCODER, AND METHOD OF PRODUCING THESE ARTICLES	TANIGUCHI, YUKIO
<u>08597400</u>	Not Issued	161	02/08/1996	MOLDED ARTICLES USING GLASS AS SUBSTRATE, SUCH AS HOLOGRAPHIC OPTICAL ELEMENT, OPTICAL REFLECTOR, AND ENCODER, AND METHOD OF PRODUCING THESE ARTICLES	TANIGUCHI, YUKIO
<u>08459663</u>	Not Issued	166	06/02/1995	HOLOGRAM RECORDING SHEET, HOLOGRAPHIC OPTICAL ELEMENT USING SAID SHEET, AND ITS PRODUCTION PROCESS	TANIGUCHI, YUKIO
<u>08451158</u>	<u>5731116</u>	150	05/26/1995	ELECTROSTATIC INFORMATION RECORDING MEDIUM AND ELECTROSTATIC INFORMATION RECORDING AND REPRODUCING METHOD	TANIGUCHI, YUKIO
<u>08416182</u>	<u>5635317</u>	250	04/04/1995	PREPARATION AND REPRODUCTION OF FILTERS AND PREPARATION OF FILTER PHOTOGRAPHIC MATERIALS	TANIGUCHI, YUKIO
<u>08201988</u>	Not Issued	161	02/25/1994	ARTIFICIAL AUDITORY OSSICLE	TANIGUCHI, YUKIO
<u>08149951</u>	<u>5543228</u>	150	11/10/1993	MOLDED RELIEF HOLOGRAM	TANIGUCHI, YUKIO
<u>08128143</u>	Not Issued	041	09/29/1993	HOLOGRAM RECORDING SHEET, HOLOGRAPHIC OPTICAL ELEMENT USING SAID SHEET, AND ITS PRODUCTION PROCESS	TANIGUCHI, YUKIO

07959476	Not Issued	161	10/09/1992	ELECTROSTATIC INFORMATION RECORDING MEDIUM AND ELECTROSTATIC INFORMATION RECORDING AND REPRODUCTION METHOD	TANIGUCHI, YUKIO
07875898	Not Issued	161	04/29/1992	CORE MATERIAL FOR CLOTHING	TANIGUCHI, YUKIO
07616445	5439768	150	11/20/1990	ELECTROSTATIC INFORMATION RECORDING MEDIUM AND ELECTROSTATIC INFORMATION RECORDING AND REPRODUCING METHOD	TANIGUCHI, YUKIO
07613684	5650247	150	11/15/1990	PREPARATION AND REPRODUCTION OF FILTERS AND PREPARATION OF FILTER PHOTOGRAPHIC MATERIALS	TANIGUCHI, YUKIO
07353084	Not Issued	166	05/17/1989	ELECTROSTATIC INFORMATION RECORDING MEDIUM AND ELECTROSTATIC INFORMATION RECORDING AND REPRODUCING METHOD	TANIGUCHI, YUKIO
06830491	4677285	150	02/19/1986	IDENTIFICATION ARTICLE WITH PATTERN-FORM FRESNEL HOLOGRAM, FABRICATION THEREOF, AND VERIFICATION THEREOF	TANIGUCHI, YUKIO
06494577	Not Issued	166	05/16/1983	IDENTIFICATION ARTICLE WITH PATTERN-FORM FRESNEL HOLOGRAM, FABRICATION THEREOF, AND VERIFICATION THEREOF	TANIGUCHI, YUKIO

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L10 and (phase shifter same (second near5 (region or area or division)))	109

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<u>L12</u>	L10 and (phase shifter same (second near5 (region or area or division)))	109	<u>L12</u>
<u>L11</u>	L10 and (phase shifter same (region or area or division))	1155	<u>L11</u>
<u>L10</u>	crystal\$ and phase shifter	4793	<u>L10</u>
<u>L9</u>	L4 and (phase shifter same (retard\$ or delay\$ or modif\$ or modulat\$))	36	<u>L9</u>
<u>L8</u>	L4 and (phase shifter same retard\$)	6	<u>L8</u>
<u>L7</u>	L4 and (circular near6 (phase or shift))	16	<u>L7</u>
<u>L6</u>	L5 and ((phase or modul\$ or shift\$) near5 second)	33	<u>L6</u>
<u>L5</u>	L4 and silicon and crystal\$	256	<u>L5</u>
<u>L4</u>	(phase or modul\$ or shift\$) same (ELA or excimer laser anneal\$)	3077	<u>L4</u>
<u>L3</u>	L2 and retar\$	55	<u>L3</u>
<u>L2</u>	L1 and (phase near3 shift\$)	234	<u>L2</u>
<u>L1</u>	crystalli\$ near3 (apparatus or device)	11287	<u>L1</u>

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<u>L5</u>	L4 and silicon and crystal\$	256	<u>L5</u>
<u>L4</u>	(phase or modul\$ or shift\$) same (ELA or excimer laser anneal\$)	3077	<u>L4</u>
<u>L3</u>	L2 and retar\$	55	<u>L3</u>
<u>L2</u>	L1 and (phase near3 shift\$)	234	<u>L2</u>
<u>L1</u>	crystalli\$ near3 (apparatus or device)	11287	<u>L1</u>

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